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Docket No.: 057810-0094

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Nobuhiko ODA, et al. : Confirmation Number: 7697

Application No.: 10/809,909 : Group Art Unit: 2871

Filed: March 26, 2004 : Examiner: Minh Toan T. Ton

For: DISPLAY

INFORMATION DISCLOSURE STATEMENT

Mail Stop Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the

10/809,909

foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Please recognize our Customer No. 20277 as our correspondence address.

SHEET 1 OF 1 SERIAL NO. INFORMATION DIS ATTY. DOCKET NO. 10/809,909 057810-0094 CITATION IN AN APPLICATION **APPLICANT** Nobuhiko ODA, et al. FILING DATE **GROUP** (PTO-1449) 2871 March 26, 2004 U.S. PATENT DOCUMENTS Pages, Columns, Lines, Where Publication Date Name of Patentee or Applicant of Cited Document Number **EXAMINER'S** CITE Relevant Passages or Relevant MM-DD-YYYY Document INITIALS Number-Kind Code2 (if known) Figures Appear Nimura 12/26/02 US 2002/0196517 A1 Shigeno et al. 03/21/02 2002/0033918 A1 US US US υŝ US LIS US US US US US US US FOREIGN PATENT DOCUMENTS Pages, Columns, Lines Translation **Publication Date** Name of Patentee or Foreign Patent Document **EXAMINER'S** Applicant of Cited Document Where Relevant INITIALS CITE Country Codes - Number 4 - Kind MM-DD-YYYY Yes No Figures Appear Codes (if known) NO. Korean (corresponding to US2002/0196517 A1 listed 2002-92824 above) Korean (corresponding to 200214993 US2002/0033918 A1 listed above) OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where **EXAMINER'S** INITIALS CITE published. NO. Office Action dated December 1, 2005 with English Translation for corresponding Korean Patent Application No. 10-2004-20813 DATE CONSIDERED **EXAMINER**

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.